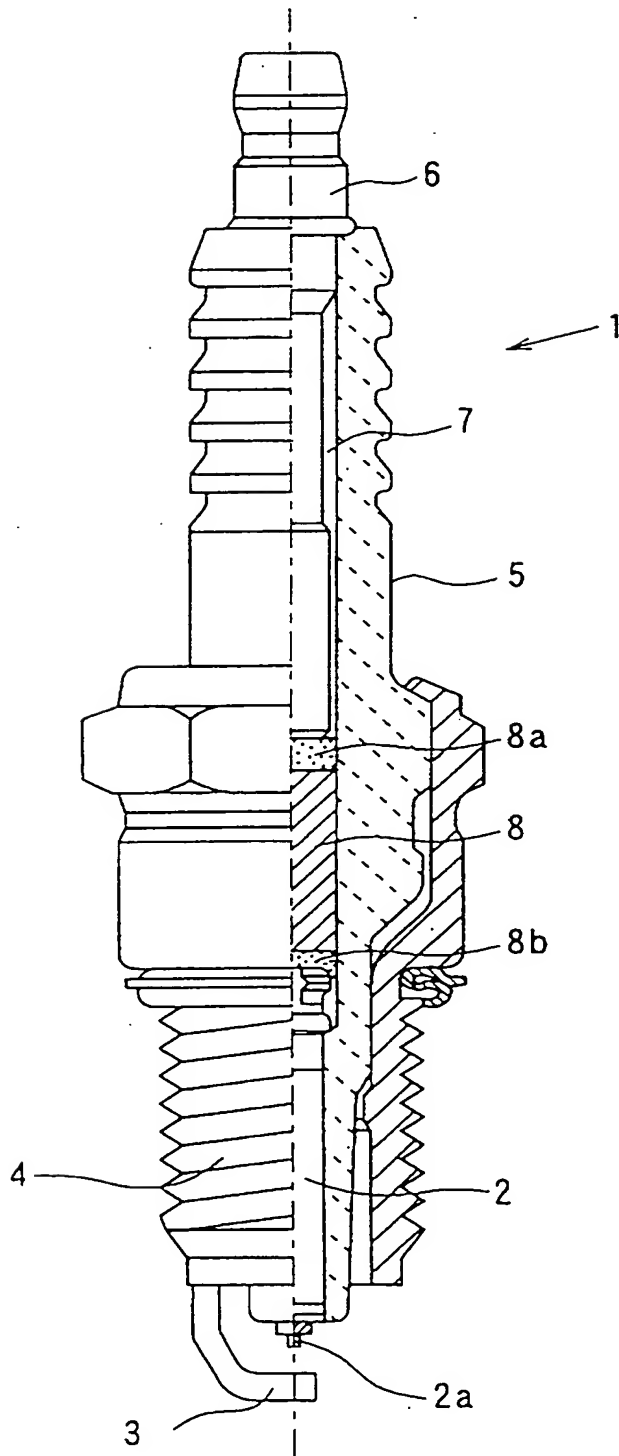


FIG. 1



FOR OFFICIAL USE ONLY

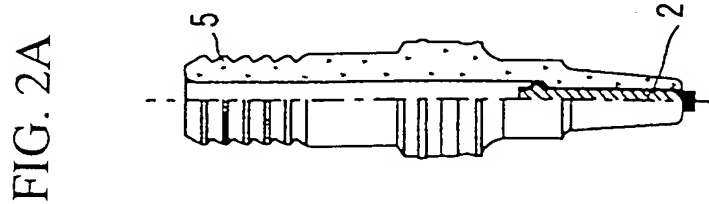


FIG. 2A  
CENTER  
ELECTRODE  
INSTALLATION

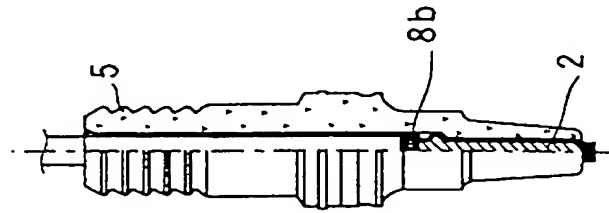


FIG. 2B  
GLASS POWDER  
STUFFING AND  
PRESS

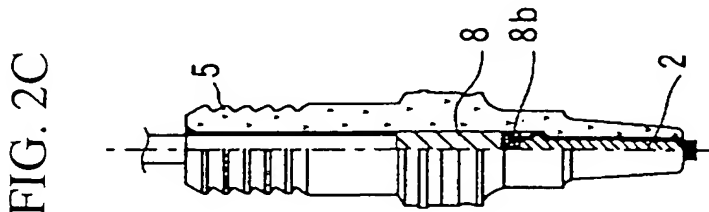


FIG. 2C  
RESISTIVE  
MATERIAL  
STUFFING  
AND PRESS

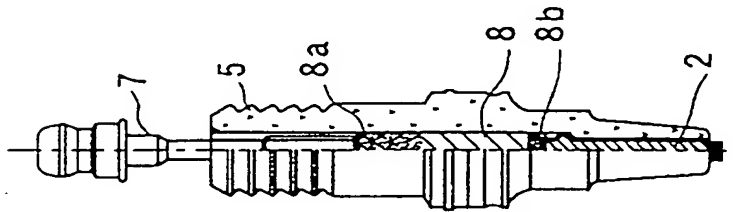


FIG. 2D  
GLASS POWDER  
STUFFING & STEM  
INSTALLATION  
AND PRESS

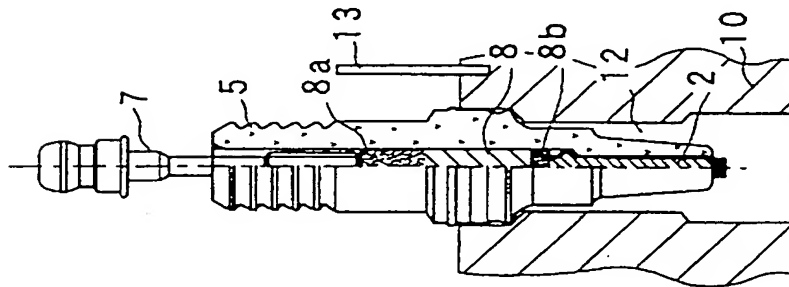


FIG. 2E  
HEATING

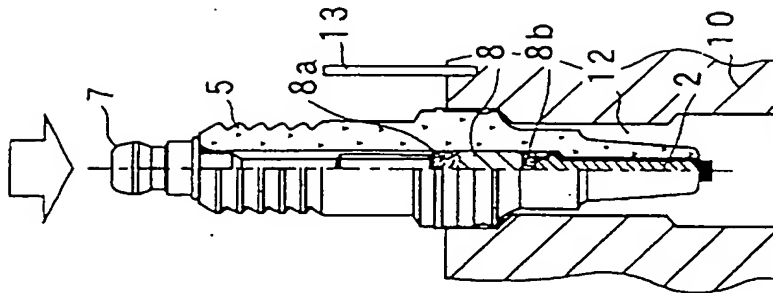
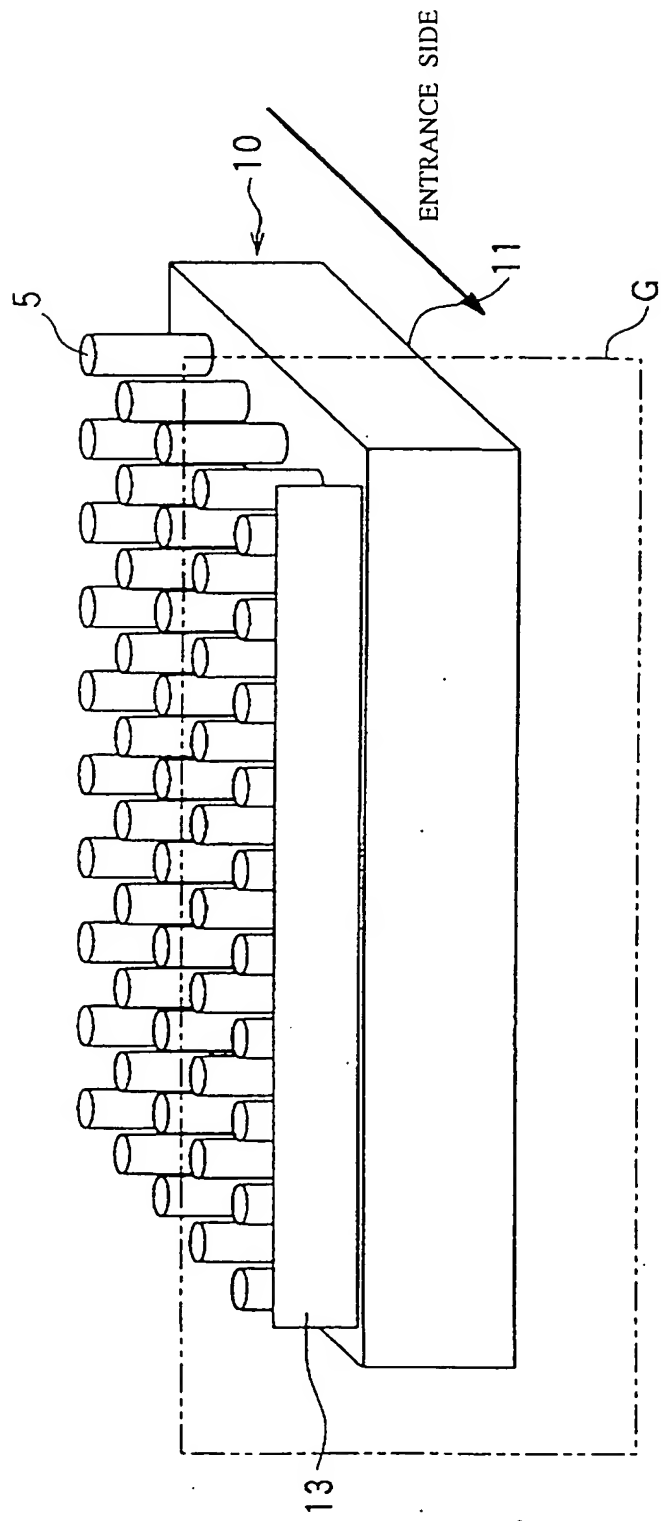


FIG. 2F  
THERMAL PRESS

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FIG. 3



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FIG. 4

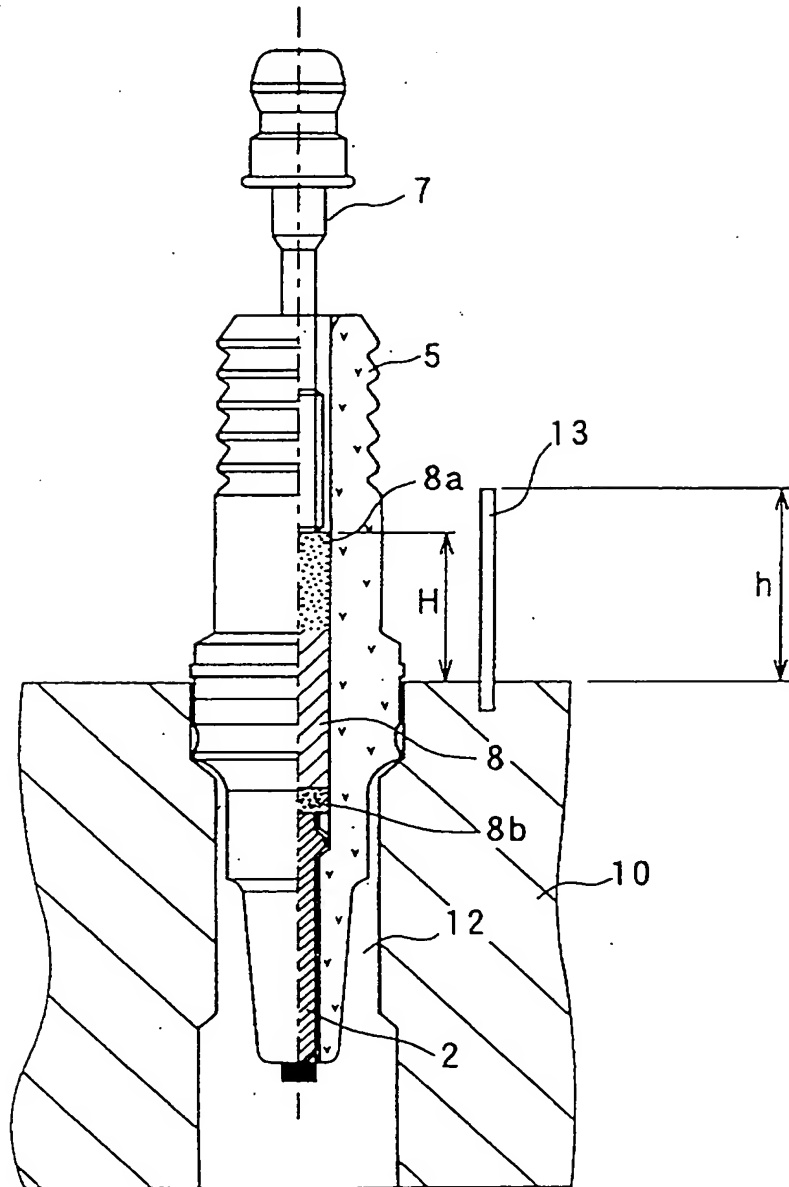
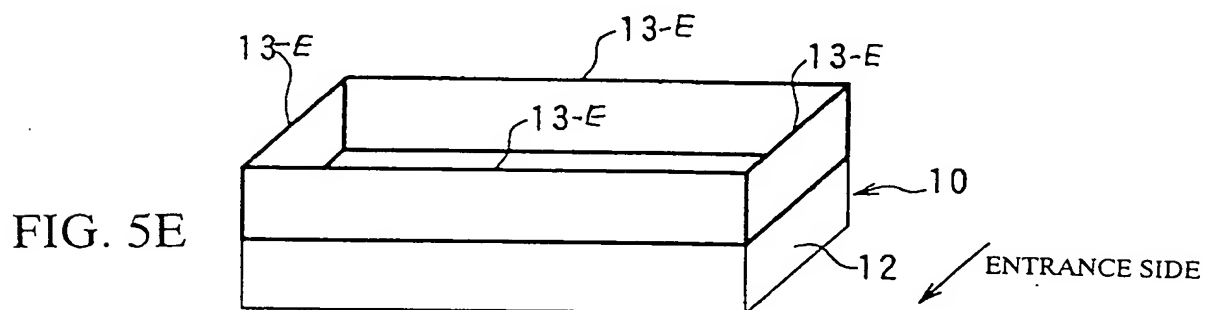
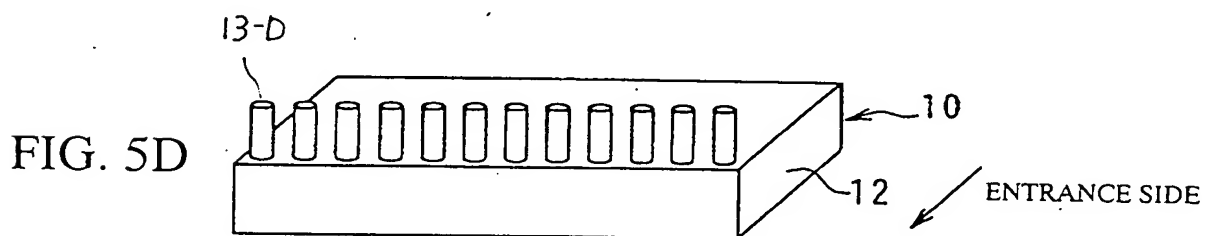
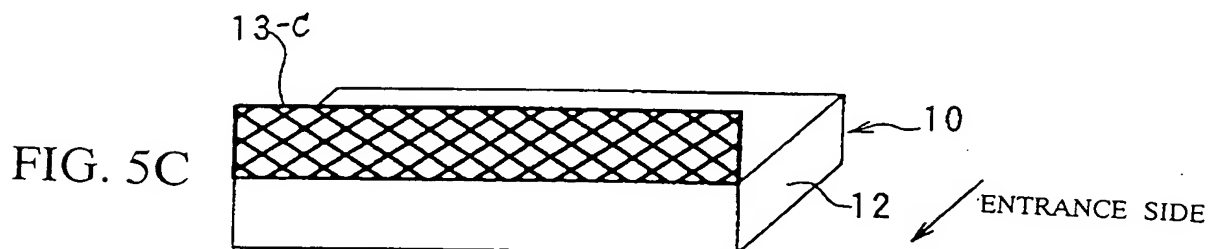
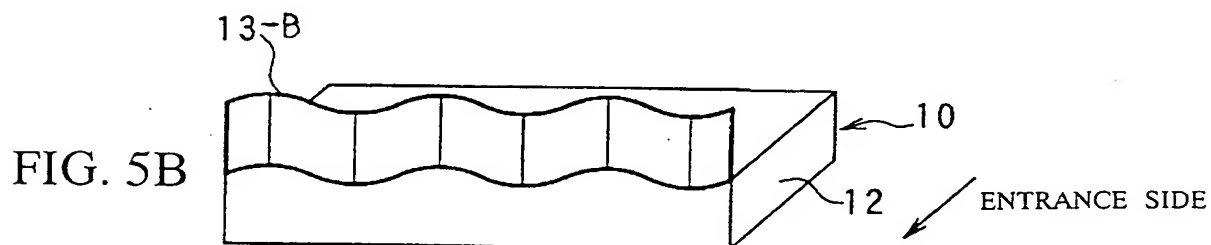
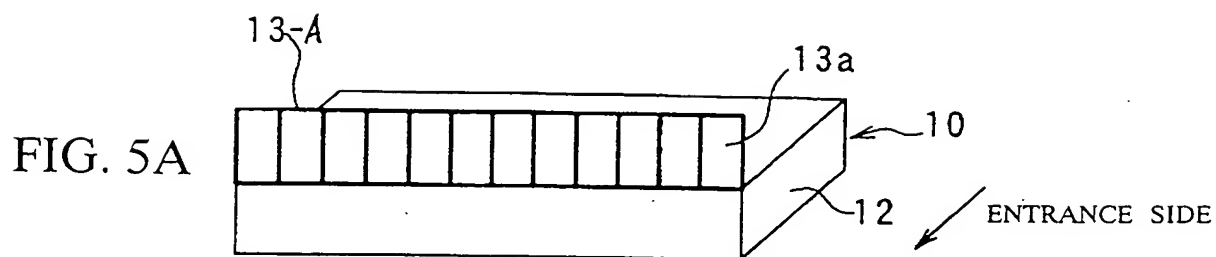
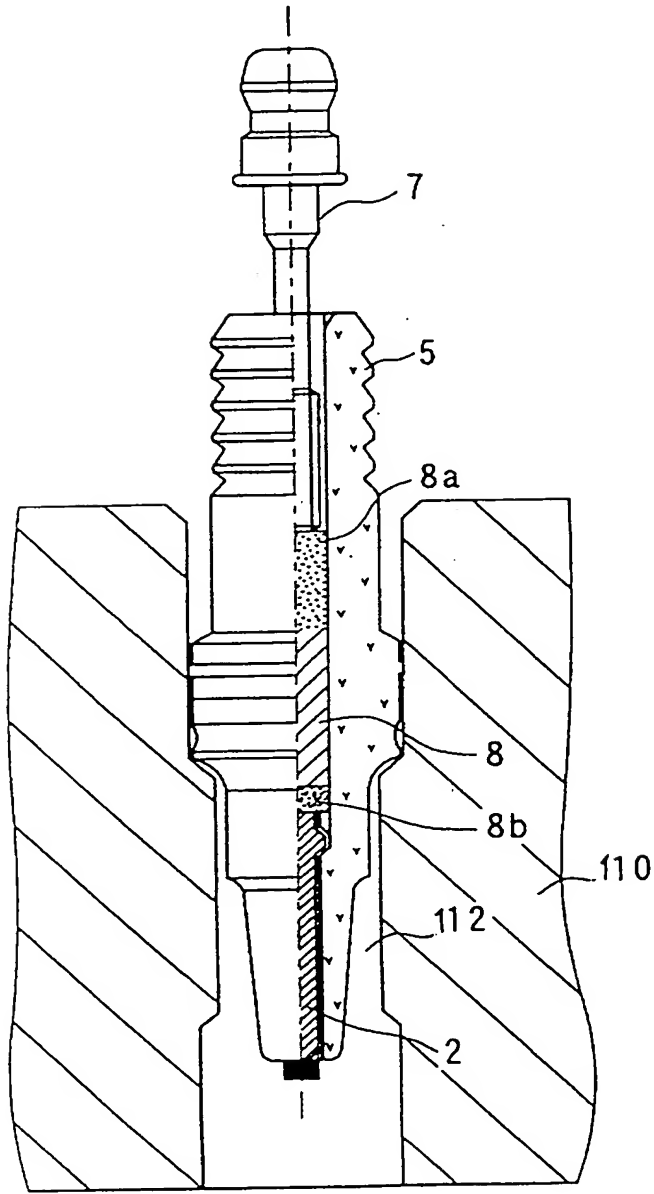


FIG. 4 is a cross-sectional view of the device of FIG. 1, taken along line 4-4 of FIG. 1, showing the device in a first position.



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FIG. 6



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FIG. 7

